

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application <b>10/712,503</b>		OFGS File No. <b>P/16-342 (Div)</b>			
		Applicant <b>Tatsuo TAKANASHI, et al.</b>					
		Filing Date		Group Art Unit <b>2873</b>			
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
AM	US-6,215,605	04-2000	Kuwana et al.	359	824		
AM	US-6,191,897	02-2001	Blake et al.	359	814		
AM	US-6,166,868	12-2000	Holderer et al.	359	819		
AM	US-6,005,723	12-1999	Kosaka et al.	359	822		
AM	US-5,986,827	11-1999	Hale, Layton C.	359	822		
AM	US-5,903,387	05-1999	Tomikawa et al.	359	412		
AM	US-5,774,266	06-1998	Otani et al.	359	554		
AM	US-5,748,390	05-1998	Koiwai et al.	359	811		
AM	US-5,606,384	02-1997	Yamazaki et al.	396	55		
AM	US-5,383,168	01-1995	O'Brien et al.	369	44.14		
AM	US-5,162,951	11-1992	Sorce, Craig J.	359	871		
AM	US-4,387,970	06-1983	Brueggemann	359	813		
AM	US-3,989,358	11-1976	Melmoth	359	813		
<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<del>59-68710</del>		<del>04-1984</del>	<del>Japan</del>				
<del>60-150511</del>		<del>10-1985</del>	<del>Japan</del>				
<del>61-46895</del>		<del>10-1986</del>	<del>Japan</del>				
<del>61-190515</del>		<del>11-1986</del>	<del>Japan</del>				
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
Examiner <b>T. Mock</b>	Date Considered <b>3/21/04</b>						
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							